	Application No.	Applicant(s)
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Notice of Allowability	10/614,224 Examiner	EGUCHI ET AL.
·		
	Richard H. Kim	2871
The MAILING DATE of this communication apperature All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIOF the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in thi or other appropriate communic IGHTS. This application is subj	is application. If not included cation will be mailed in due course. THIS
1. This communication is responsive to 3/16/05.		
2. The allowed claim(s) is/are <u>1-15</u> .		
3. \boxtimes The drawings filed on <u>08 July 2003</u> are accepted by the Ex	aminer.	
 4. Acknowledgment is made of a claim for foreign priority una) All b) Some* c) None of the: Certified copies of the priority documents have Certified copies of the priority documents have Copies of the certified copies of the priority documents have Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). * Certified copies not received: 	been received. been received in Application N	lo
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	of this communication to file a r IENT of this application.	eply complying with the requirements
5. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give		
 CORRECTED DRAWINGS (as "replacement sheets") muse (a) including changes required by the Notice of Draftspers 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner's Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in the such as the sheet of the such as the sheet of the such as the sheet of the such as the	on's Patent Drawing Review (Formula). S Amendment / Comment or in the decision on the decision of the decisio	the Office action of
7. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT	sit of BIOLOGICAL MATERI FOR THE DEPOSIT OF BIOLO	AL must be submitted. Note the oGICAL MATERIAL.
Attachment(s) 1. □ Notice of References Cited (PTO-892) 2. □ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 10/30/03 4. □ Examiner's Comment Regarding Requirement for Deposit of Biological Material	6. ☐ Interview Sumr Paper No./Mai 8), 7. ☐ Examiner's Am	

DETAILED ACTION

Allowable Subject Matter

1. Claims 1-15 allowed.

2. The following is an examiner's statement of reasons for allowance: The prior art taken alone or in combination, fails to teach or disclose in light of the specifications, a method of manufacturing a liquid crystal display device comprising severing the pair of substrates along a line drawn between the opening and the panel region after injecting the liquid crystal.

Tamatani (US 5,893,625) discloses severing a pair of substrates and injecting the liquid crystal, but does disclose that injecting the liquid crystal is performed after the pair of substrates are severed.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Richard H. Kim whose telephone number is (571)272-2294. The examiner can normally be reached on 9:00-6:30 M-F.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Robert H. Kim can be reached on (571)272-2293. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Art Unit: 2871

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Richard H Kim Examiner Art Unit 2871

RHK

TARIFUR R. CHOWDHURY PRIMARY EXAMINER